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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
MASARU SASAKI, ET AL. : EXAMINER: MALEK, M.
SERIAL NO: 10/591,343 :
FILED: AUGUST 31, 2006 : GROUP ART UNIT: 2813
FOR: METHOD FOR MANUFACTURING :
SEMICONDUCTOR DEVICE AND
PLASMA OXIDATION METHOD

AMENDMENT AND REQUEST FOR RECONSIDERATION

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Responsive to the Office Action of December 8, 2010, Applicants request reconsideration in view of the following amendment and remarks submitted concurrently with a Terminal Disclaimer.

Remarks begin on page 2 of this paper.